IFW

Application Number 10/701,035

Filling Date November 3, 2003

First Named Inventor Hung, Chi-Yuan

Art Unit 1756

Examiner Name ROSASCO, STEPHEN D

(to be used for all correspondence after initial filing)	- Laminer Hame	ROSASCO, STEPHEN D
Total Number of Pages in This Submission	Attorney Docket Number	021653-002800US
ENCLOSURES (Check all that apply)		
Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Addres Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on CD	After Allowance Communication to TC Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm Name Townsend and Townsend and Crew LLP		
Signature		
Printed name Kent J. Tobin		
Date October 5, 2005	Reg. No.	39,496
CERTIFICATE OF TRANSMISSION/MAILING		
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.		
Signature Eleanar J. Taylor		
Typed or printed name Eleanor J. Taylor	/ /	Date October 5, 2005

I hereby cent that this correspondence is being deposited with the United States Postal Services ass mail in an envelope addressed to:

PATENT

Attorney Docket No.: 021653-002800US

Client Ref. No.: I-02-051

Mail Stop Amendment Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

on October 5, 2005

TOWNSEND and TOWNSEND and CREW LLP

By: Eleanor J. Vaylor

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Chi-Yuan Hung

Application No.: 10/701,035

Filed: November 3, 2003

For: METHOD AND STRUCTURE FOR FABRICATING PATTERNS ON PHASE SHIFT MASK FOR THE MANUFACTURE OF SEMICONDUCTOR WAFERS

Customer No.: 20350

Confirmation No. 6151

Examiner:

Stephen D. Rosasco

Technology Center/Art Unit: 1756

RESPONSE TO OFFICE ACTION

Mailed July 13, 2005

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 13, 2005, please enter the following amendments and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 8 of this paper.

Remarks/Arguments begin on page 12 of this paper.